

Sir:

PATENT Customer No. 22,852 Attorney Docket No. 8071.0007

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)
Takeshi MITSUISHI et al.	) Group Art Unit: 2872
Application No.: 09/986,907	) ) Examiner: Joshua Pritchett
Filed: November 13, 2001	) )
For: COMPOSITION FOR VAPOR DEPOSITION, METHOD FOR FORMING AN ANTIREFLECTION FILM, AND OPTICAL ELEMENT	) Confirmation No.: 6647 ) )
Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450	

## TRANSMITTAL LETTER

Enclosed is a reply to the Office Action of April 8, 2004. The item(s) checked below are appropriate:

Applicants hereby petition for a three month extension of time to respond to the above Office Action. The fee of \$1,020.00 for the Extension is enclosed.

The claims are calculated below:

	Claims Remaining After Amendment		Highest Number Previously Paid	Present Extra	Rate	/	Additional Fee
Total	54	-	35	19	x \$ 50	\$	950.00
Indep.	5	-	3	2	x \$200		400.00
First	Presentation of Multip	le De	o. Claim(s)	L	+\$360		
					Subtotal	\$	1,350.00
		-	Reducti	ion by ½ if sr	nall entity	-	<u></u>
					TOTAL	\$	1,350.00

A fee of \$1,350.00 to cover the cost of the additional claims added by this reply is enclosed.

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A fee of \$790.00 to cover Request for Continued Examination
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A check for \$3,160.00 to cover the above fee(s) is enclosed.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Dated: February 7, 2005

Charles E. Van Horr Reg. No. 40,266